

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/820,209	<b>Applicant(s)/Patent under Reexamination</b> LUNAK ETAL
	<b>Examiner</b> Kimberly D. Nguyen	<b>Art Unit</b> 2876

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner